



INTERNATIONAL
GEMOLOGICAL
INSTITUTE

ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

September 26, 2025

IGI Report Number **LG737545800**

Description **LABORATORY GROWN DIAMOND**

Shape and Cutting Style **ROUND BRILLIANT**

Measurements **6.59 - 6.61 X 4.11 MM**

GRADING RESULTS

Carat Weight **1.09 CARAT**

Color Grade **D**

Clarity Grade **VVS 2**

Cut Grade **IDEAL**

ADDITIONAL GRADING INFORMATION

Polish **EXCELLENT**

Symmetry **EXCELLENT**

Fluorescence **NONE**

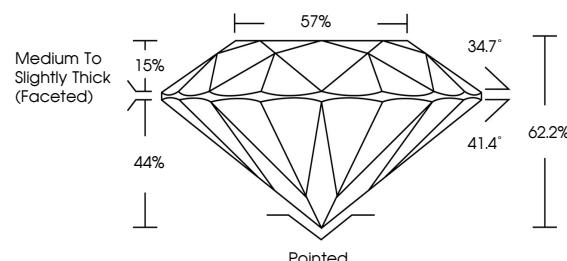
Inscription(s) **IGI LG737545800**

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.

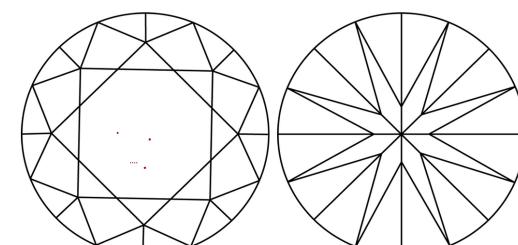
Type Ila

LG737545800
Report verification at igi.org

PROPORTIONS



CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.

Green symbols indicate external characteristics.

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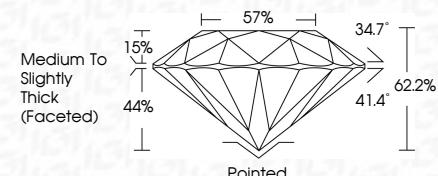
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Sample Image Used



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September 26, 2025	IGI Report No LG737545800	ROUND BRILLIANT	1.09 CARAT	D	VVS 2	IDEAL	0.25	67%	Pointed	EXCELLENT	EXCELLENT	NONE	IGI LG737545800
		Color Grade			Clarity Grade								
		Depth			Cut Grade								
		Table			Table								
		Girdle			Girdle								
		Medium to Slightly Thick (Faceted)			Medium to Slightly Thick (Faceted)								
		57%			57%								
		34.7°			34.7°								
		41.4°			41.4°								
		62.2%			62.2%								
		44%			44%								
		15%			15%								
		Pointed			Pointed								

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